

**CERTIFICATE OF ELECTRONIC  
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I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1792, via EFS-WEB on May 4, 2010.



5/4/10

David H. Brinkman, Reg. No. 40,532

Date

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Martin Hausner  
Serial No. : 10/524,525  
Filed : August 18, 2005  
Confirmation No. : 1134  
Group Art Unit : 1792  
Examiner : Ahmed, Shamim  
Title : **METHOD FOR SELECTIVELY REMOVING MATERIAL  
FROM THE SURFACE OF A SUBSTRATE, MASKING  
MATERIAL FOR A WAFER, AND WAFER WITH MASKING  
MATERIAL**  
Attorney Docket No. : BEET-09

Cincinnati, Ohio 45202

May 4, 2010

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**SUPPLEMENTAL AMENDMENT**

In response to the Office Action mailed on November 3, 2009 and supplementing the Amendment filed on May 3, 2010, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.